

Applicant: Sung-Jin KIM, Seung-Hyun CHANG and Ki-Heum NAM
Serial No. not yet assigned Examiner: not yet assigned
Filing Date: October 14, 2003 Group: not yet assigned
For: PHOTO MASK SET FOR FORMING MULTI-LAYERED INTERCONNECTION LINES
AND SEMICONDUCTOR DEVICE FABRICATED USING THE SAME

INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Issue</u> <u>Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub</u> <u>Class</u>
_____	_____	5,242,770	9/7/1993	Chen et al.		

FOREIGN PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Publication</u> <u>Date</u>	<u>Country</u>	<u>Name</u>
_____	_____				

OTHER DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
_____	_____	

Examiner: _____

Date Considered: _____